

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of)
Shinji MAEKAWA et al.)
Japanese Priority Application No. 2002-340167) Attn: Applications
Japanese Priority Date: November 22, 2002) Branch
For: METHOD FOR FABRICATING)
THIN FILM TRANSISTOR) Date: November 17, 2003

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Please preliminarily amend the subject application as follows: